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## **.070 piece of solid polystyrene - PC-DMIS User Forum**

A: In order to access this tool go to the CMms / Laser Data and press the button labelled Close. As you can see on the screen below if you are in quick pickup mode i.e. all the sensors on the CMms are turned on then you will be asked for the CSV entry, once complete the tool will process the CMms. Notice that all the lasers should turn off. This means that the CSV for this tool has at least one value of length or depth that will not be used for a laser on the CMms. Apparatus and methods for the thermal processing of semiconductor substrates are known in the art. For instance, plasma-assisted etching methods are known in the art as well as ion milling. Plasma-assisted etching is usually used to cut bulk silicon to a particular shape with a high degree of surface finish. Plasma etching can also be used to remove a layer of silicon from a substrate by means of a combination of the sputtering effect of ions accelerated across a plasma discharge and a chemical reaction between etching species generated by the discharge. Plasma etching is widely used for removal of thin layers of silicon, such as photoresist, polycrystalline silicon, amorphous silicon, or low temperature oxides. Plasma etching is preferred to wet etching as wet etchants tend to undercut the features on the silicon substrate. Ion milling is a process where a sharpened silicon tip, or mill, is used to cut through the silicon substrate. Ion milling produces a pattern that could be utilized for many purposes. For example, the pattern on a wafer could be used to precisely place features. Alternatively, the pattern of an array of balls could be used to form an integrated circuit with less assembly. In any case, ion milling is a high resolution technique that can be used in many circumstances where other techniques, such as plasma etching, can be used. During the thermal processing of a silicon substrate, it is very important to remove any contaminants, such as particles and gases, from the surface of the silicon substrate. Particles and gases on the surface of a silicon substrate may affect the yield or the performance of the silicon substrate. Particles and gases on the surface of the silicon substrate can negatively affect the yield or performance of the silicon substrate, in which case the substrate may be more difficult to polish to remove all of the substrate and therefore more difficult to recast. Also, removing

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